

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. .... 09/389,533  
 Priority Filing Date ..... September 2, 1999  
 Inventor ..... Alan R. Reinberg  
 Assignee ..... Micron Technology, Inc.  
 Priority Group Art Unit ..... 2823  
 Priority Examiner ..... T. Pham  
 Attorney's Docket No. .... MI22-1952  
 Title: Methods of Forming Capacitors and Resultant Capacitor Structures

**PRELIMINARY AMENDMENT**

To: Assistant Commissioner for Patents  
 Washington, D.C. 20231

From: Frederick M. Fliegel, Ph.D.  
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Sir:

This is a preliminary amendment accompanying a Request for Continuation Application for the above-entitled patent application. Prior to examining the application, please enter the following amendments.

**AMENDMENTS**

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